

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

---

In re application of: Ismail EMESH et al.                      Group Art Unit: 3723  
Serial No.:                      10/729,119                      Examiner:      Shakeri, Hadi  
Filed:                      December 4, 2003                      Confirmation No.: 3177  
For:                      LUBRICANT FOR WAFER POLISHING USING A FIXED  
                                 ABRASIVE PAD  
Attorney Docket No.: 004.0122

---

**RESPONSE AND AMENDMENT**

MAIL STOP AMENDMENT  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is responsive to the non-final Office Action mailed on August 25, 2006.  
Please amend the above-identified application as set forth below.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.